Docket No.: APPM/008657/DISPLAY/AKT/RKK 1016.012168 (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE tion of:

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In re Application of:

Soo Y. Choi et al.

Serial No.: 10/823,347

Confirmation No : 4736

Filed: April 12, 2004

For: GAS DIFFUSION SHOWER HEAD DESIGN FOR

LARGE AREA PLASMA ENHANCED CHEMICAL VAPOR DEPOSITION

Group Art Unit: 1763

Examiner:

S. Chandra

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated September 26, 2007, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 7 of this paper. Payment of fees for the one month extension is authorized on a separate fee transmittal. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/008657/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.